

Supplementary Information

Template-free formation of oriented oxide nanowalls via topotactic-like pseudomorphic transformation: [110]-MgO(111) nanowall arrays

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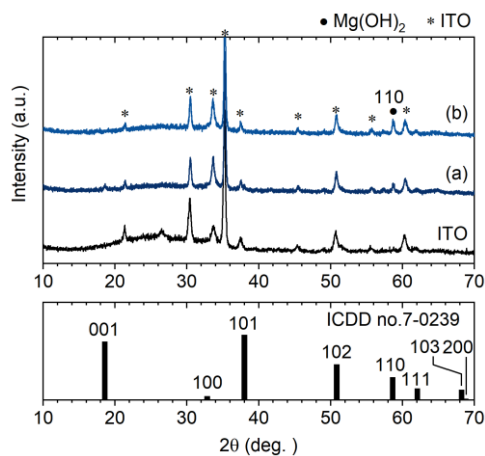


Figure S1. XRD patterns of as-deposited Mg(OH)₂ nanowall (NW) arrays electrodeposited on an ITO substrate with controlled grain size: (a) large-grain and (b) small-grain NWs obtained at an initial current density of (a) 0.5 and (b) 4.0 mA cm⁻² for 40 and 5 s, followed by a constant current of 0.2 mA cm⁻² for ~4.2 min, respectively.

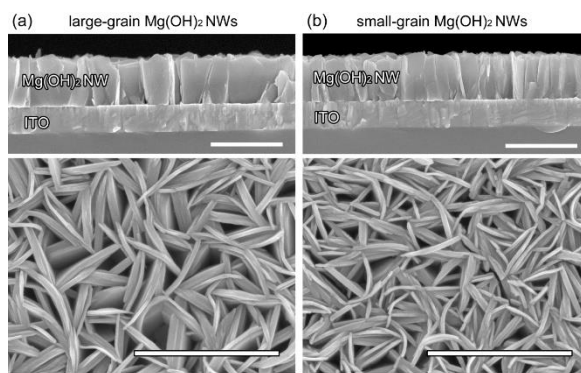


Figure S2. Cross-sectional (top) and surface (bottom) FESEM images of as-deposited Mg(OH)₂ nanowall (NW) arrays electrodeposited on an ITO substrate with controlled grain size: (a) large-grain and (b) small-grain NWs obtained at an initial current density of (a) 0.5 and (b) 4.0 mA cm⁻² for 40 and 5 s, followed by a constant current of 0.2 mA cm⁻² for ~4.2 min, respectively.

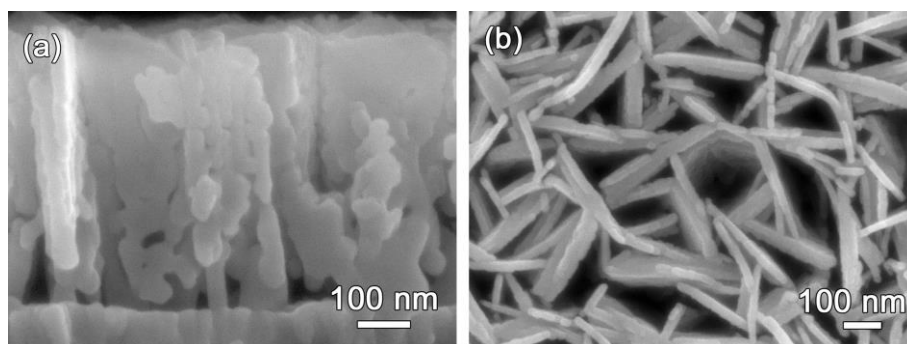


Figure S3. (a) Cross-sectional and (b) surface FESEM images of MgO nanowalls obtained by heating Mg(OH)₂ NWs at 800 °C for 2 h in air.

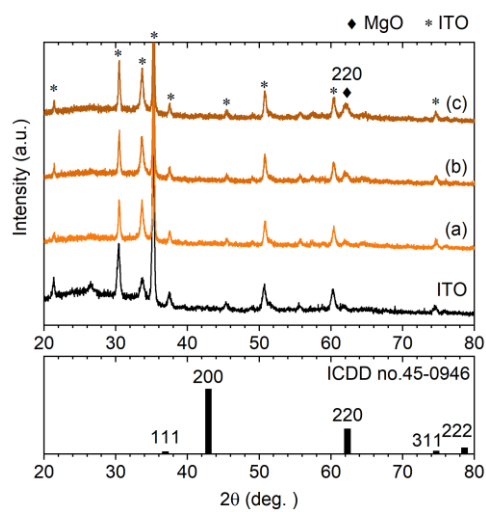


Figure S4. XRD patterns of MgO NWs obtained by heating Mg(OH)₂ NWs at 500 °C for 2 h in air: the electrodeposition time of Mg(OH)₂ is (a) 1.7, (b) 4.2 and (c) 8.3 min.